

6. (Amended) The ink jet recording apparatus according to claim 1,  
 wherein said ink jet head on which said plurality of nozzles is arranged  
 comprises cavities provided for each of said nozzles, a reservoir communicating to said  
 cavities and common to said nozzles, and a supply port for supplying said functional liquid to  
 said reservoir; and  
 wherein said plurality of groups comprise at least a first group comprising  
 nozzles of said plurality of nozzles positioned close to said supply port, and a second group  
 comprising nozzles of said plurality of nozzles positioned far from said supply port.

9. (Amended) The method for manufacturing a functional liquid applied  
 substrate according to claim 7,  
 wherein said ink jet head on which said plurality of nozzles is arranged  
 comprises cavities provided for each of said nozzles, a reservoir communicating to said  
 cavities and common to said nozzles, and a supply port for supplying said functional liquid to  
 said reservoir; and  
 wherein said plurality of groups comprise at least a first group comprising  
 nozzles of said plurality of nozzles positioned close to said supply port, and a second group  
 comprising nozzles of said plurality of nozzles positioned far from said supply port.

10. (Amended) A method for manufacturing a device comprising a functional  
 liquid applied substrate manufactured by the method according to claim 7.

12. (Amended) A device comprising a functional liquid applied substrate  
 manufactured by the method according to claim 7.

# REMARKS

Claims 1-12 are pending. By this Preliminary Amendment, claims 5, 6, 9, 10 and 12  
 are amended to remove multiple dependencies. The specification is amended to correct a  
 typographical error. No new matter is added. Prompt and favorable examination on the  
 merits is respectfully requested.